# Wire Bond Testing in AMS

### Topics

AMS-2 SSD laddersBonding process issues

- ASI's acceptance criteria
- Strategy of G & A Engineering
- QA
- Traceability
- Results and conclusions

### **AMS-2 SSD ladders**

- The AMS-2 silicon tracker counts about 250 (incl. spares) ladders of various lengths
- AMS-2 silicon sensors are 2-sided, with 192x641 strips to connect
- A typical ladder with 12 Si sensors needs more than 12000 bonds
- G & A Engineering is manufacturing on Oricola plant 125 ladders with lengths between 12 and 15 sensors – involve over 1500000 bonds



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## **Bonding process issues**

 SSD's are connected to each other and to readout hybrids by means of a Upilex<sup>®</sup> cable

Bond types (as substrate stiffness):

- Wire Silicon
- Wire Upilex
- Wire Capacitor

Bond pad shape and repairs





![](_page_8_Picture_0.jpeg)

#### ASI's acceptance criteria

🔀 Microsoft Excel - NewAcCrit.xls										
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D19 =										
					Bond acceptance criteria					
								· •		
	Quantity					lim.	value	unit	remarks	
Upilex-Silicon bonding										
	missing bonds					<	0.1	%	max value	
	bonds in short with adjacent ch's					<	0.1	%	max value	
	bonding strength				>	5	gf	min value during bonding on test structures (bond loop angle 30 degrees)	;	
	bonding strength					>	9	gf	average value during bonding on test structures (bond loop angle 30 degrees)	:
Upilex-hybrid bonding									385 bonds	
	missing bonds				<	1	%	max value		
	bonds i	n short	: with a	adjacen	t ch's	<	1	%	max value	
	bonding	g streng	gth			>	5	gf	min value during bonding on test structures (bond loop angle 30 degrees)	-
	bonding strength					>	9	gf	average value during bonding on test structures (bond loop angle 30 degrees)	-
Silicon-Silicon bonding									644*(n-1) = 9016 bonds max	T
	missing bonds				<	0.1	%	max value		
	bonds i	n short	: with a	adjacen	t ch's	<	0.1	%	max value	
	bonding strength				>	5	gf	min value during bonding on test structures (bond loop angle 30 degrees)		
	bonding strength						9	gf	average value during bonding on test structures (bond loop angle 30 degrees)	-
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#### Strategy of G & A Engineering

 Avoiding the failed bonds by adapting the bond process parameters to the substrate properties and variability

 Optical inspection of pads before bonding

### QA

- 100% inspection of incoming parts
  Customized bonder software and fixtures for auto-adjusting bond parameters to variability of materials
- Destructive pull test on wafer cutoffs
- Non-destructive daily pull tests

#### Traceability

#### Online documentation of assembly process

![](_page_12_Picture_2.jpeg)

#### Conclusions

- Analysis of bonding incidents on a sample of 76 ladders manufactured by G&A Engineering:
  - 74 ladders with no failed bond
  - 1 ladder with 1 missing bond
  - 1 ladder with 3 missing bonds
- Conclusion: 76 ladders present 4 missing bonds only, compared to >900 allowed by acceptance criteria